

PATENT
930055-2031

2834

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

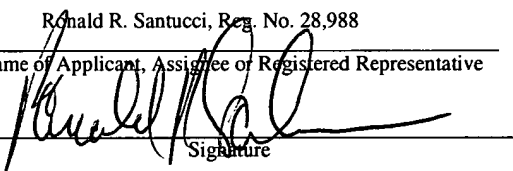
Applicant(s) : Tetsuo YAMADA, Kosuke NISHIMURA, Keigo NAGAO
Serial No. : 10/518,704
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN
FILM PIEZOELECTRIC DEVICE, AND
MANUFACTURING METHOD THEREOF (as proposed
for amendment)
Filing Date : December 17, 2004
Examiner : Not Yet Assigned
Group Art Unit : 2834
Confirmation No. : 5674

745 Fifth Avenue
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Alexandria, VA 22313-1450, on August 18, 2005.

Ronald R. Santucci, Reg. No. 28,988

Name of Applicant, Assignee or Registered Representative



Signature

August 18, 2005

Date of Signature

SECOND PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the examination of the above referenced patent application,

Applicants respectfully request that the application be further amended as follows:

In the Title:

Applicants respectfully request that the title of the application be amended as follows:

THIN FILM PIEZOELECTRIC ~~OSCILLATOR~~ RESONATOR, THIN FILM
PIEZOELECTRIC DEVICE, AND MANUFACTURING METHOD THEREOF